

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Park, Young-woo; Noh, Jun-yong; Koo, Bon-young;
Kang, Chang-jin; Jung, Chul; Nam, Seok-woo
Assignee: Samsung Electronics Co., Ltd.
Title: Semiconductor Memory Device And Method Of Manufacturing For
Preventing Bit Line Oxidation
Serial No.: 09/008,525 Filed: 01/16/98
Examiner: Not Assigned Group Art Unit: 2811
Docket No.: AB-778 US

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San Jose, California
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**INFORMATION DISCLOSURE STATEMENT WITH
CERTIFICATION UNDER § 1.97(e)(1)**

Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, Applicant(s) wish to call the following documents (copies enclosed) to the attention of the Examiner. The documents were cited in the enclosed European Search Report for the corresponding European Application No. EP 98 30 0304.

A PTO form 1449 listing these documents is enclosed.

The relevance of any non-English language documents cited herein is explained in the accompanying copy of the Abstract.

Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, other than as described above; or

3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

The undersigned hereby certifies in accordance with § 1.97(e)(1) that each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: ASSISTANT COMMISSIONER FOR PATENTS, Washington, D.C. 20231, on March 21, 2000.

David T. Millers

Attorney for Applicants

3-21-00

Date of Signature

Respectfully submitted,

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U.S. Department of Commerce, Patent and Trademark Office						Any Docket No.		Serial No.	
						AB-778 US		09/008,525	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT						Applicant(s)			
(Use several sheets if necessary)						Park, Young-woo; Noh, Jun-yong; Koo, Bon-young; Kang, Chang-jin; Jung, Chul; Nam, Seok-woo			
						Filing Date		Group	
						01/16/98			
U.S. Patent Documents									
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
	AA	5,126,280	06/30/92	Chan et al.	437	52			
	AB	5,196,364	03/23/93	Fazan et al.	437	52			
	AC	5,330,614	07/19/94	Ahn	156	631			
	AD	5,445,999	08/29/95	Thakur et al.	437	242			
	AE								
	AF								
	AG								
	AH								
	AI								
	AJ								
	AK								
Foreign Patent Documents									
							Translation		
		Document	Date	Country	Class	Subclass	Yes	No	
	AL	EP 0 539 233	04/28/93	Europe	HO1L				
	AM								
	AN								
	AO								
	AP								
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)									
	AQ	Japanese Abstract - Manufacture Of Semiconductor Storage Device, 1 page; Publication Number: 09139478; Publication Date: May 27, 1997							
	AR								
	AS								
Examiner			Date Considered						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.									